

Substitute for form 1449/PTO  <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> <i>(Use as many sheets as necessary)</i>				Complete if Known		
				Application Number	09/715,935	
				Filing Date	November 17, 2000	
				First Named Inventor	Bi et al.	
				Art Unit	1762	
				<b>RECEIVED CENTRAL FAX CENTER OCT 19 2007</b>		
Examiner Name	Stouffer, K.					
Attorney Docket Number	2950.16US02					
Sheet	1	of	1			
<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER INITIAL <sup>1</sup>	Cite No. <sup>1</sup>	Document Number  Number-Kind Code <sup>2</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document		
/KMS/		US-4,011,067	03-08-1977	Carey, Jr.		
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EXAMINER INITIAL <sup>1</sup>	Cite No. <sup>1</sup>	Foreign Patent Document  Country Code <sup>3</sup> Number <sup>4</sup> Kind Code <sup>5</sup> (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	T <sup>6</sup>	
/KMS/		GB 2 185 494	07-22-1987	Cureton		
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		WO 00/026151	05-18-2000	Cain et al.		
<b>NON PATENT LITERATURE DOCUMENTS</b>						
EXAMINER INITIAL <sup>1</sup>	Cite No. <sup>1</sup>	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published			T <sup>6</sup>	
/KMS/		TSUKAMOTO ET AL., "A New Ceramic Coating Technique for SOFC Using the ETL Laser Spraying Process", Solid State Ionics, 40/41 (1990), 1003-1006.				
EXAMINER SIGNATURE	/Kelly Stouffer/		DATE CONSIDERED	11/29/2007		
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